

2023 CS MANTECH Workshop Agenda



Topic
Workshop Opening
Lithography
Optical Lithography (line, DUV)
E-Beam Lithography
Morning Break
Deposition
Metal Plating
Atomic Layer Deposition (ALD)
Lunch
Materials
MOCVD Epitaxy Growth
MBE Epitaxy Growth
Engineered Substrates/Characterization
Afternoon Break
Integration
TBD
Wafer-Level Packaging
Workshop Closing